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Direct growth of graphene on vertically standing glass by a metal-

free chemical vapor deposition method

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A new method to directly grow graphene on quartz glass substrate by atmospheric-pressure chemical vapor deposition (CVD) without using any catalyst was developed. The prime feature of this method is to build a vertical-glass model in the quartz tube to significantly increase the collision probability of the carbon precursors and reactive fragments between each other with the glass surface. The growth rate of high-quality graphene on glass remarkably increases compared with the conventional gas flow CVD technique. The optical transmittance and sheet Download English Version:

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